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AMENDMENTS TO THE CLAIMS

This claim set replaces all previous versions of the claims.

- 1. (Currently Amended) A fast scanning stage for a scanning probe microscope, said scanning probe microscope including a probe, said stage comprising, at least one fixed support, and a sample stage having at least one axis of translation, said sample stage being affixed to said at least one fixed support by [[and]] means for causing displacement of said stage relative to said probe.
- 2. (Original) A fast scanning stage as claimed in claim 1 in which said means for causing displacement of said sample comprise at least one actuator element supporting said stage and a sine waveform generator for actuating said at least one actuator element.
- 3. (Currently Amended) A fast scanning stage as claimed in claim 2 in which said means for causing displacement of said sample <u>stage</u> comprise four actuator elements supporting said stage.
- 4. (Currently Amended) A fast scanning stage as claimed in claim 2 for a scanning probe microscope, said scanning probe microscope including a probe, said fast scanning stage comprising at least one fixed support and a sample stage having at least one axis of translation, said sample stage being affixed to said at least one fixed support by at least one actuator element, a sine waveform generator for actuating said at least one actuator element, in which said stage is displaced by said at least one actuator element being driven at the frequency of resonant vibration corresponding to translation of said sample with respect to said probe.
- 5. (Original) A fast scanning stage as claimed in claim 3 in which said stage has a square or rectangular configuration and each corner of said stage is supported by one of said actuator elements.
- 6. (Original) A fast scanning stage as claimed in claim 5 in which said actuator elements form a parallelogram scanning element.

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7. (Original) A fast scanning stage as claimed in claim 6 in which said actuator elements are

connected electrically in parallel.

8. (Original) A fast scanning stage as claimed in claim 2 in which said at least one actuator

element comprises a stack bending element.

9. (Original) A fast-axis scanning stage as claimed in claim 2 in which said at least one actuator

element comprises a PZT bimorph.

10. (Original) A fast-axis scanning stage as claimed in claim 3 in which said at least one actuator

element comprises a PZT bimorph.

11. (Original) A fast-axis scanning stage as claimed in claim 1 in which said stage is comprised

of a material selected from the group consisting of ceramics, heat resistant polymers, and

anodized aluminum.

12. (Currently Amended) A scanning probe microscope including a probe and a fast scanning

stage, said fast scanning stage comprising at least one fixed support, and a sample stage having at

least one axis of translation, said sample stage being affixed to said at least one fixed support by

[[and]]at least one actuator element supporting said stage to cause displacement of said stage

relative to said probe.

13. (Currently Amended) A method of operating a fast scanning stage for a scanning probe

microscope, said scanning probe microscope including a probe, comprising, providing a sample

stage having a sample thereon and causing displacement of said stage relative to said probe by

actuating at least one actuator element to drive said stage at its resonant frequency using a sine

waveform generator.

14. Canceled.

15. (Original) A method as claimed in claim [[14]] 13 in which the resonant frequency of said stage is about 1/100th that of the resonant frequency of said probe.